#### MILITARY SPECIFICATION

SEMICONDUCTOR DEVICE, TRANSISTOR, NPN, SILICON, POWER TYPES 2N5152, 2M5154, JAN, JANTX & JANTXV

This specification is approved for use by the Rome Air Development Center, Department of the Air Force, and is available for use by all Departments and Agencies of Defense.

#### 1. SCOPE

- 1.1 Scope. This specification covers the detail requirements for NPN, silicon, power transistors for use in high-speed power-switching applications. Three levels of product assurance are provided for each device type as specified in MIL-S-19500.
  - 1.2 Physical dimensions. See Figure 1 (TO-39)
  - 1.3 Maximum ratings.

$T_A = 25^{\circ}C$	$r_{c} = 25^{\circ}c$	<sup>V</sup> СВО	VCEO	VEBO	<sup>I</sup> c	L -	Reverse Pulse 4/ Energy	Safe Operat- ing Area	istg
<u>W</u>	<u>₩</u> 11.8	Vdc 100	80 80	<u>Vdc</u> 5.5	Adc 2	Adc 10	m <u>J</u> 15	See Figure 5	oc -65 to +200

- 1/ Derate linearly 5.7 mw/°C for  $T_A > 25°C$ 2/ Derate linearly 66.7 mw/°C for  $T_C > 25°C$ 3/ This value applies for  $P_W \le 8.3$  ms, duty cycle  $\le 1\%$ 

  - $\overline{4}$ / This rating is based on the capability of the transistors to operate safely in the unclamped inductive load energy test circuit of Figure 4.
- 1.4 Primary electrical characteristics at  $T_r = 25^{\circ}C$ .

LIMITS	hFE2 VCE = 51 IC = 2	. 5A	h <sub>fe</sub> V <sub>CE</sub> = 5V I <sub>C</sub> = 500 f = 10 M 2N5152 2	mA Hz	Ic = 5 Adc	VCE(sat)2 I <sub>C</sub> = 5 Adc I <sub>B</sub> = 500 mAdc	C <sub>Obo</sub> v <sub>CB</sub> = 10Vdc I <sub>E</sub> = 0 f = 1 MHZ	<sup>R</sup> ⊕J-C
Min Max	30 90	70 200	6	7	<u>Vdc</u>  2.2	<u>Vdc</u>  1 . 5	_pF  250	0 <u>C/W</u>  15

### 1/ Pulsed (See 4.5.1)

Beneficial comments (Recommendations, additions, deletions) and any pertinent data which may be used in improving this document should be addressed to: Rome Air development Center, RADC, Griffiss AFB, NY 13441 by using the self-addressed Standardization Document Improvement Proposal (DD Form 1426) appearing at the end of this document or by letter.

FSC5961

#### 2. APPLICABLE DOCUMENTS

2.1 Issues of documents. The following documents, of the issue in effect on date of invitation for bids or request for proposal, form a part of the specification to the extent specified herein.

SPECIFICATION

MILITARY

MIL-S-19500 - Semiconductor Devices, General Specification for.

STANDARD

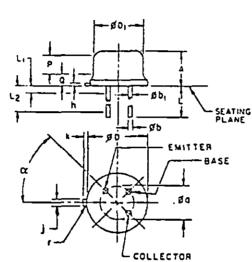
MILITARY

XIL-STD-750 - Test Methods for Semiconductor Devices

(Copies of specifications, standards, drawings, and publications required by suppliers in connection with specific procurement functions should be obtained from the procuring activity or as directed by the contracting officer).

#### REQUIREMENTS

- 3.1 Detail Specification. The individual item requirements shall be in accordance with MIL-S-19500 and is specified herein.
- 3.2 Abbreviations, symbols and definitions. The abbreviations, symbols and definitions used nerein are defined in HIL-S-19500.
- 3.3 Design, construction and physical dimensions. The design, construction and physical dimensions shall be as specified in MIL-S-19500 and Figure 1 herein.
- U.3.1 <u>Lead Material and Finish</u>. Lead material shall be xovar or alloy 52. Lead finish shall be gold plated, tin plated or solder dipped. Where a choice of lead material or finish is desired, it shall be specified in the contract or procurement document. (See 6.3)
- 3.3.2 <u>Current Density</u>. Current density of internal conductors shall be as specified in 3.6.5 of MIL-S-19500.
- 3.4 Marking. Marking shall be in accordance with MIL-S-19500, except country of origin may be omitted.
  - 4. QUALITY ASSURANCE PROVISIONS
- 4.1 <u>Sampling and inspection</u>. Sampling and inspection shall be accordance with MIL-S-19500, and as specified herein.
- 4.2 Qualification inspection. Qualification inspection shall be in accordance with MIL-S-19500.

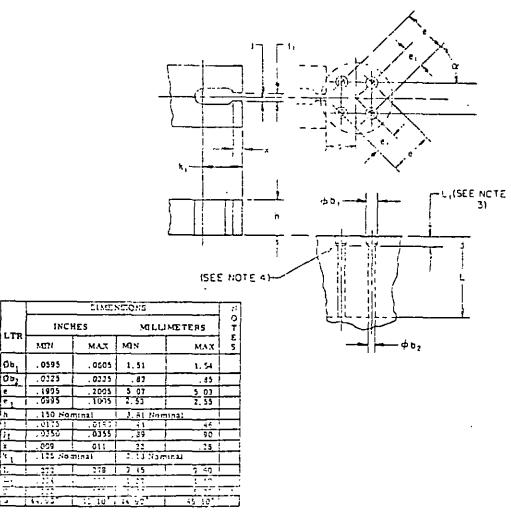


	DIMENSIONS						
LTR	INC	HES	MILL	T			
511	MIN	MAX	MIN	MAX	E S		
A	. 240	260	6.10	5.60			
On I	. 200	TP	5. 08	TP	6		
Ob	. 016	. 021	. 41	, 53	7.8		
ØЬ	.016	.019	. 41	. 48	7, 8		
ØD	. 335	. 370	8.51	9.40			
OD <sub>1</sub>	. 305	. 335	7. 75	8.51			
h	. 009	041	. 23	1.04			
[j_:[	. 028	. 034	. 71	, 86	2		
k	. 029	. 045	. 74	1.14	3		
L	. 500	.750	12,70	19.05	7, 8		
L		. 050	• • • •	1.27	7, 8		
L <sub>2</sub>	. 250		6.35		7, 8		
P	.100		2.54		5		
Q		. 050		1.27	4		
Г		.010		. 25	10		
α	45	TP	45	TP	6		

#### NOTES:

- Metric equivalents (to the nearest .01 mm) are given for general information only and are based upon 1 inch = 25.4 mm.
- 2. Beyond r (radius) maximum, j shall be held for a minimum length of .011 (.28 mm)
- 3. k measured from maximum OD.
- 4. Outline in this zone is not controlled.
- 5. OD<sub>1</sub> shall not vary more than .010 (.25 mm) in zone P. This zone is controlled for automatic handling.
- 6. Leads at gage plane .054 + .001 .000 (1.37 + .03 .00 mm) below seating plane shall be within .007 (.18 mm) radius of true position (TP) at maximum material condition (MMC) relative to tab at MMC. The device may be measured by direct methods or by the gage and gaging procedure shown in figure 2.
- 7. Obj applies between  $L_1$  and  $L_2$ . Ob applies between  $L_2$ -and L minimum. Diameter is uncontrolled in  $L_1$  and beyond L minimum.
- 8. All three leads.
- 9. The collector shall be electrically and mechanically connected to the case.
- 10. r (radius) applies to both inside corners of tab.

FIGURE 1. Physical dimensions



#### NOTES:

- The location of the tab locator within the limits indicated will be determined by the tab and flance dimensions of the device being checked.
- 2. Gaging procedure. The device being measured shall be inserted until its seating plane is .125 ±.010 (3.18 ±.25 mm) from the seating surface of the gage. A force of 8 ±.5 oz shall then be applied parallel and symmetrical to the device's cylindrical axis. When examined visually after the force application (the force need not be removed) the seating plane of the device shall be seated against the gage. The use of a pin straightener prior to insertion in the gage is permissible.
- 3. Gaging plane.
- 4. Drill angle.

FIGURE 2. Gage for lead and tab location

4.3 Screening JANTX and JANTXV levels only. Screening shall be in accordance with MIL-S-19500 (Table II) and as specified herein. The following measurements shall be made in accordance with Table I herein. Devices that exceed the limits of Table I herein shall not be accepted.

Screen (see Table II of MIL-S-19500)	Measurements JANTX, JANTXV levels
11	ICES1 and hFE2
12	See 4.3.1
13	Subgroup 2 of Table I herein: $^{I}CES_{1}$ = +100% of initial value or 100 na whichever is greater $^{\Delta}$ $^{h}FE2$ = $\pm$ 20%

4.3.1 <u>Power burn-in conditions</u>. Power burn-in conditions (TX and TXV) are as follows.

2N5152, 2N5154 
$$V_{CE} = 40V$$
  $P_{\pm} = 1.0W$   $T_{A} = 25 \pm 3^{\circ}C$ 

NOTE: No heat sink or forced air cooling on the device shall be permitted.

- 4.4 Quality conformance inspection. Quality conformance inspection shall be in accordance with IIL-S-19500.
- 4.4.1 <u>Group A inspection</u>. Group A inspection shall be conducted in accordance with MIL-S-19500 and Table I herein. Endpoint electrical measurements shall be in accordance with the applicable steps of Table IV, herein.
- · 4.4.2 <u>Group B inspection.</u> Group B inspection shall be conducted in accordance with the conditions specified for subgroup testing in Table IVb (JAN, JANTX, and JANTXV) of MIL-S-19500, and Table II herein. Electrical measurements (end points) and delta requirements shall be in accordance with the applicable steps of Table IV herein.
- 4.4.3 <u>Group C inspection.</u> Group C inspection shall be conducted in accordance with the conditions specified for subgroup testing in Table V of MIL-S-19500 and Table III herein. Electrical measurements (endpoints) and delta requirements shall be in accordance with the applicable steps of Table IV herein.

TABLE I Group A inspection

		MIL-STD-750	LTPD		Lin	its	
Examination or test	Method	Conditions	JAH/TX TXV	Symbol	Min	May	Units
Subgroup 1			5				
lisual and mechan- ical examination	2071						
Subaroup 2			5				
Sreakdown voltage collector to amitter	3011	Bias condition D. I. = 100 mAdc ID = D Pulsed (see 4.5.1)		V(BR)CEO	80		Vdc
,	20.1	<u>.</u>		_			
Collector to emit- ter cutoff cur- rent	3041	Sias condition C, VCE = 60 Vdc VBE = 0	;	<sup>I</sup> CES1	- <b>-</b>	1.0	uA dc
Collector to emic- ter cuttoff cur- rent	3041	Bias condition C, VCE = 100 Vdc VBE = 0	:	<sup>I</sup> CES2		1.0	mAdc
Collector to emita- ter cutoff cura- rent	3041	Bias condition D, VCE = 40 Vdc IB = 0		<sup>I</sup> CEO		50	u4 dc
Edition to base successful current	3061	Sies condition D. YES = 4 YES IC = 0	į	EBGT		1.0	⊾A dc
Emitter to base cutoff current	3061	Bias condition D, VEB = 5.5 'Vdc IC = 0		I <sub>EB02</sub>		1.0	mA dc
Forward - current transfer ratio	3076	YCE = 5 Vdc ICE = 50 mAdc		h <sub>FE1</sub>			
2N5152 2N5154		Pulsed (see 4.5.1)			20 50	 	
Forward - current transfer ratio	3076	VCE = 5 Vdc ICE = 2.5 Adc		h <sub>FE2</sub>			
2N5152 2N5154		Pulsed (see 4.5.1)			30 70	90 200	

## TABLE I Group A inspection

	!	MIL-STD-750	LTPD		Lim	ts	
Examination or test	Method	Conditions	JAN/TX TXV	Symbol	Min	Max	Units
Subgroup 2 (con't	-						
Forward - current transfer ratio	3076	V <sub>CE</sub> = 5 Vdc		h <sub>FE3</sub>			
	i	I <sub>C</sub> = 5 Adc					
2N51 52 2N51 54		Pulsed(see 4.5.1)			20 40		
Base-emitter volt- age (non-	3066	Test condition B V <sub>CE</sub> = 5 Vdc		V <sub>BE</sub>		1.45	Vác
saturated)	•	I <sub>C</sub> = 2.5 Adc Pulsed(see 4.5.1)					
Base-emitter satu-	3066	Test condition A		V <sub>BE(sat)1</sub>		1.45	Vdc
ration voltage		I = 2.5 Adc I = 250 mAdc					
Base-emitter satu-	3066	Pulsed(see 4.5.1) Test condition A		VBE(sat)2		2.2	Vdc
ration voltage		I <sub>C</sub> = 5 Adc I <sub>B</sub> = 500 mAdc		52(500)			
	i	Pulsed(see 4.5.1)					
Collector-emitter saturation voltage	3071	I <sub>C</sub> = 2.5 Adc I <sub>B</sub> = 250 mAdc		VCE(sat)1	••	0.75	Vdc
J		Pulsed(see4.5.1)				, ,	
Collector-emitter saturattion voltage	3071	I <sub>C</sub> = 5 Adc I <sub>B</sub> = 500 mAdc		VCE(sat)2		1.5	Vdc
	ĺ	Pulsed(see 4.5.1)	5		:		
Subgroup 3 High temperature operation:	ļ	T <sub>C</sub> = 150°C	3				
Collector to	3041	Bias condition A		ICEX	••	500	иAdc
current		V = 60 Vdc VBE = -2 Vdc		•			
	{						
j	1	į	1				

TABLE I Group A inspection

		MIL-STD-750	LTPD	T	Li	mits	T
Examination or test	Method	Conditions	JAN/TX TXV	Symbol	Min	Max	Units
Subgroup 3 (con't)					<del>                                     </del>		<del> </del>
Low temperature operation:		T <sub>C</sub> = -55°C					
Forward - current transfer ratio	3076	V <sub>CE</sub> = 5 Vdc I <sub>C</sub> = 2.5 Adc		h <sub>FE4</sub>			
2H3132 2H3154		Poised (see 4.5.1)			15 25		
Subgroup 4			5				
Common-emitter  small-signal  short-circuit  forward-current  transfer ratio	3205	$V_{CE} = 5 \text{ Vdc}$ $I_{C} = 100 \text{ mAdc}$ $f = 1 \text{ KHz}$		<sup>h</sup> fe			
2N5152 2N5154					20 50		
Magnitude of common-emitter small-signal chart-circuit forward-current transfer ratio	3306	V <sub>CE</sub> = 5 Vdc I <sub>C</sub> = 500 mAdc f = 10 мч <sub>2</sub>		h fe			
2N5152 2N5154					6 7		
Open-circuit output capaci- tance	3236	V <sub>CB</sub> = 10 Vdc I <sub>E</sub> = 0 f = 1 MHz		C <sub>obo</sub>		250	pF

TABLE I Group A inspection

		MIL-STD-750	LTPD		Lim	its	
Examination or Test	Method	Conditions	JAN/TX TXV	Symbol	Min	Max	Units
Switching time		I = 5 Adc IC = 500 mAdc		t on		0.5	υS
		I <sub>B2</sub> = -500 mAdc		ts		1.4	μS
		$V_{BE}(off) = 3.7Vdc$		tf		0.5	ъ\$
		RL = 6 Ω (see Figure 3)		toff		1.5	μS
Subgroup 5 Safe operating area (D.C.)	3055	Pre-pulse condition for each test:  VCE = 0  IC = 0  TC = 25°C  Pulse condition for each test:  t = 1 sec.	10				5
Test # 1		l cycle T <sub>C</sub> = 25°C (see Figure 5) V <sub>CE</sub> = 5.8 Vdc I <sub>C</sub> = 2.0 Adc		•			
Test # 2		V <sub>CE</sub> = 32 Vdc I <sub>C</sub> = 340 mAdc		j			
Test # 3		V <sub>CE</sub> = 80 Vdc I <sub>C</sub> = 20 mAdc					
	}						
		·					

TABLE I Group A inspection

	N	IL-STD-750	LTPD		Lin	its	1
Examination or test	Method	Conditions	JAN/TX TXV	Symbol	Min	Max	Units
Safe operating area (unclamped inductive)		T <sub>C</sub> = 25°C 2 <sub>86</sub> = 10 Ω R <sub>BE2</sub> = 100 Ω					
		L = 0.3 mH RL = 0.1 n VCC = 10 Vdc VBB <sub>1</sub> = 10 Vdc VBB <sub>2</sub> = 4 Vdc I <sub>CM</sub> = 10 Adc (see Figure 4)					
End point electrical measurements Subroups 6 and 7		See Table IV Steps 1,2,3					

TABLE II Group B inspection (all quality levels)

		MIL-STD-750	
Examination or test	Method	Conditions	LTPD
Subgroup 1			15
Solderability	2026		
Resistance to solvents	1022		
Subgroup 2			10
Thermal shock (temperature cycling)	1051		
Hermetic seal a. Fine leak b. Gross leak	1071	<ul> <li>a. Test condition G or H</li> <li>Leak rate = 1X10<sup>-8</sup> atm</li> <li>cc/Sec.</li> <li>b. Test condition A,C,D or</li> </ul>	F
Electrical measurement		See Table IV, steps 1, 2 and 3	
Subgroup 3			5
Steady state life	1027	340 hrs, $V_{CB} = 40 \text{ Vdc}$ $P_{T} = 1W$ , $T_{A} = 25^{\circ}\text{C}$	·
Electrical measurement		See Table IV, steps 1, 2, 4 and 5	
Subgroup 4			
Decap internal visual design verification	2075		l device /O failure for each lot
Bond strength	2037	All internal wires are to be pulled	20 (C=0)
Subgroup 5			15
Thermal resistance	3131	See 4.5.2	

TABLE II Group B inspection (all quality levels)

		MIL-STD-750	LTPD	
Examination or test	Method	Conditions		
Subgroup 6			7	
High temperature life (non-operating)	1032	$T_{A} = 200^{\circ}$ C t = 340 hrs		
Electrical measurement		See Table IV, steps 1, 2, 4 and 5		
			l	
	:			

# TABLE III Group C inspection (all quality levels)

		MIL-STD-750	
Examination or test	Method	Conditions	LTPD
Subgroup 1			15
Physical dimensions	2066	(See figure 1)	
Subgroup 2			10
Thermal shock (glass strain)	1056	Test condition B	
Terminal strength	2036	Test condition E	
Hermetic seal a. Fine leak	1071	a. Test condition G or H Leak rate = 1 X 10 <sup>-8</sup> atm.cc/sec.	
b. Gross leak		b. Test condition A. C, D or F	
Moisture resistance	1021	Omit initial conditioning	
External visual	2071		·
Electrical measurement		See table IV, steps 1 2 and 3	
Subgroup 3			10
Shock	2016		
Vibration, variable frequency	2056		
Constant acceleration	2066	10,000 G	J
Electrical measurement		Table IV, steps 1, 2 and 3	
Subgroup 4			15
Salt atmosphere (corrosion)	1041		,

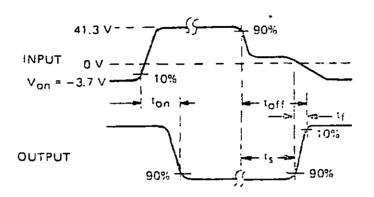
TABLE III Group C inspection (all quality levels)

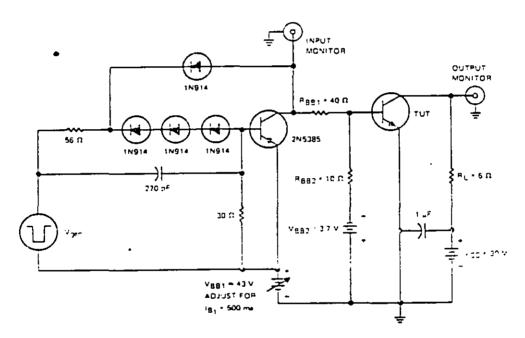
	MIL-STD-750		
Examination or test	Method	Conditions	LTPD
Subaroup 5			
Not applicable			
<u>Subgroup 6</u>			\=10
Steady state operation life	1025	T <sub>A</sub> = 25°C 1000 hours	
		V <sub>CB</sub> = 40 Vdc	İ
		P <sub>T</sub> = 1 W	
Electrical measurement		Table IV, steps 1, 2, 4 and 5	
			İ
·			

TABLE IV Groups A, B and C Electrical Measurements

5
ax Units
0 µAdc
0
Vdc
f 1 or ver ater
nitial
e a

<sup>1/</sup> Devices which exceed the Group A limits for this test shall not be accepted





- A.  $V_{gen}$  is a -30 V pulse (from OV) into a 50 ohm termination.
- B. The V waveforms is supplied by a generator with following characteristics:  $t_r \le 15$  ns,  $t_f \le 15$  ns,  $Z_{out} = 50$  ohm, duty cycle  $\le 2\%$ ,  $t_W = 20~\mu S$ .
- C. Waveforms are monitored on an oscilloscope with the following charactersitics:  $t_r \leq 15$  ns,  $R_{in} \geq 10$  M ohm,  $C_{in} \leq 11.5$  pF.
- D. Resistors must be noninductive types.
- E. The d-c power supplies may require additional bypassing in order to minimize ringing.

FIGURE 3 Switching Time Test Circuit

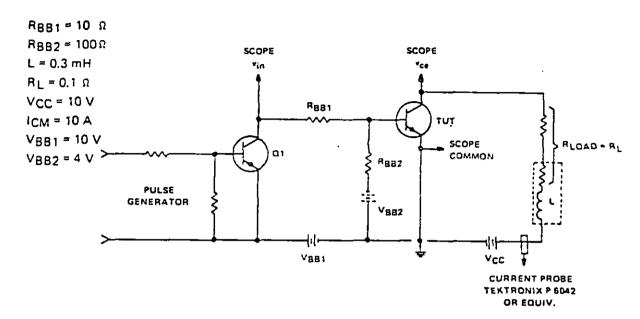


FIGURE 4 Unclamped Inductive Load Energy Test Circuit

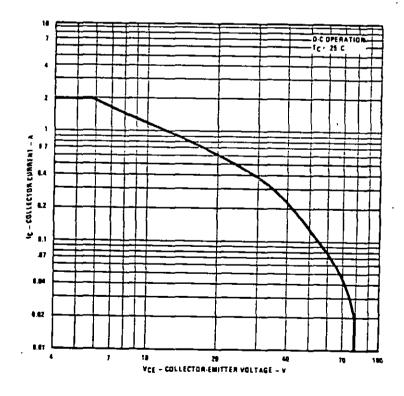


FIGURE 5 Maximum Safe Operating Area

- 4.5 Methods of examination and test. Methods of examination and test shall be as specified in the appropriate tables and as follows:
- 4.5.1 Pulse measurements. Conditions for pulse measurements shall be as specified in Section 4 of MIL-STD-750.
- 4.5.2 Thermal resistance. Thermal resistance measurements shall be conducted in accordance with Method 3131 of MIL-STD-750. The following details shall apply:
  - a. Collector current magnitude during power application shall be 500 m Adc.
  - b. Collector to emitter voltage magnitude shall be 10 Vdc.

  - c. Reference temperature measuring point shall be the case. d. Reference point temperature shall be within the range  $T_r \ge 25^{\circ} \text{C} \le 75^{\circ} \text{C}$ . Actual temperature shall be recorded.

  - e. Mounting arrangement shall be with heat sink to case. f. Maximum limit of  $R_{\mbox{\scriptsize QJC}}$  shall be  $15.0^{\mbox{\scriptsize O}}\mbox{\scriptsize C/W}.$
- 4.5.3 <u>Inspection conditions.</u> Unless otherwise specified herein all inspections shall be conducted at a case temperature ( $T_c$ ) of 25°C.
  - PACKAGING
- 5.1 <u>Packaging requirements</u>. The requirements for packaging shall be in accordance with MIL-S-19500.
  - 6. NOTES
- 6.1 Notes. The notes specified in MIL-S-19500 are applicable to this specification.
- 6.2 <u>Complimentary Use</u>. The devices specified herein are designed for complimentary use with the 205151 and 205153.
  - 6.3 <u>Ordering Data.</u> Procurement documents should specify the following:
    - a. Lead finish (see 3.3.1)

Custodian Air Force - 17 Preparing activity Air Force - 17

Review activities Air Force - 11, 19, , 85, 99 DSA- FC

Agent

DLA-EC

(FSC5961F-791)

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